



2621  
#4

501.40830X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): HIROI, et al

Serial No.: 09/986,299

Filed: November 8, 2001

For: PATTERN INSPECTION METHOD AND APPARATUS

Group: 2621

Examiner:

**RECEIVED**

**MAY 08 2002**

**PROPOSED AMENDMENT TO THE DRAWINGS  
AND CORRECTED SUBSTITUTE DRAWINGS**

**Technology Center 2600**

Commissioner for Patents  
Washington, D.C. 20231

May 3, 2002

Sir:

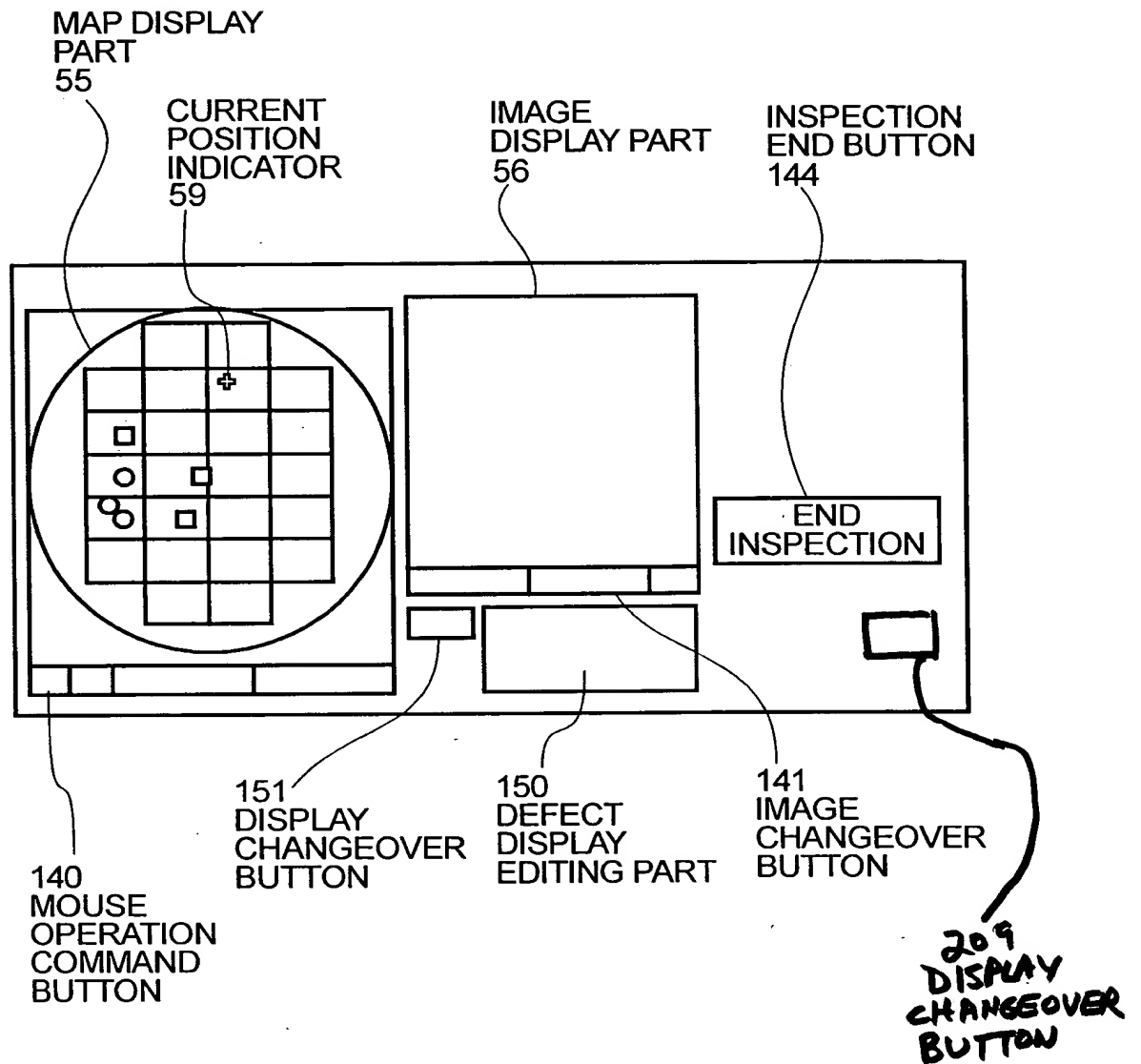
It is proposed that the drawings in the above-identified application be amended in accordance with the attached red-lined print and corrected drawings incorporating the changes are submitted herewith.

Respectfully submitted,

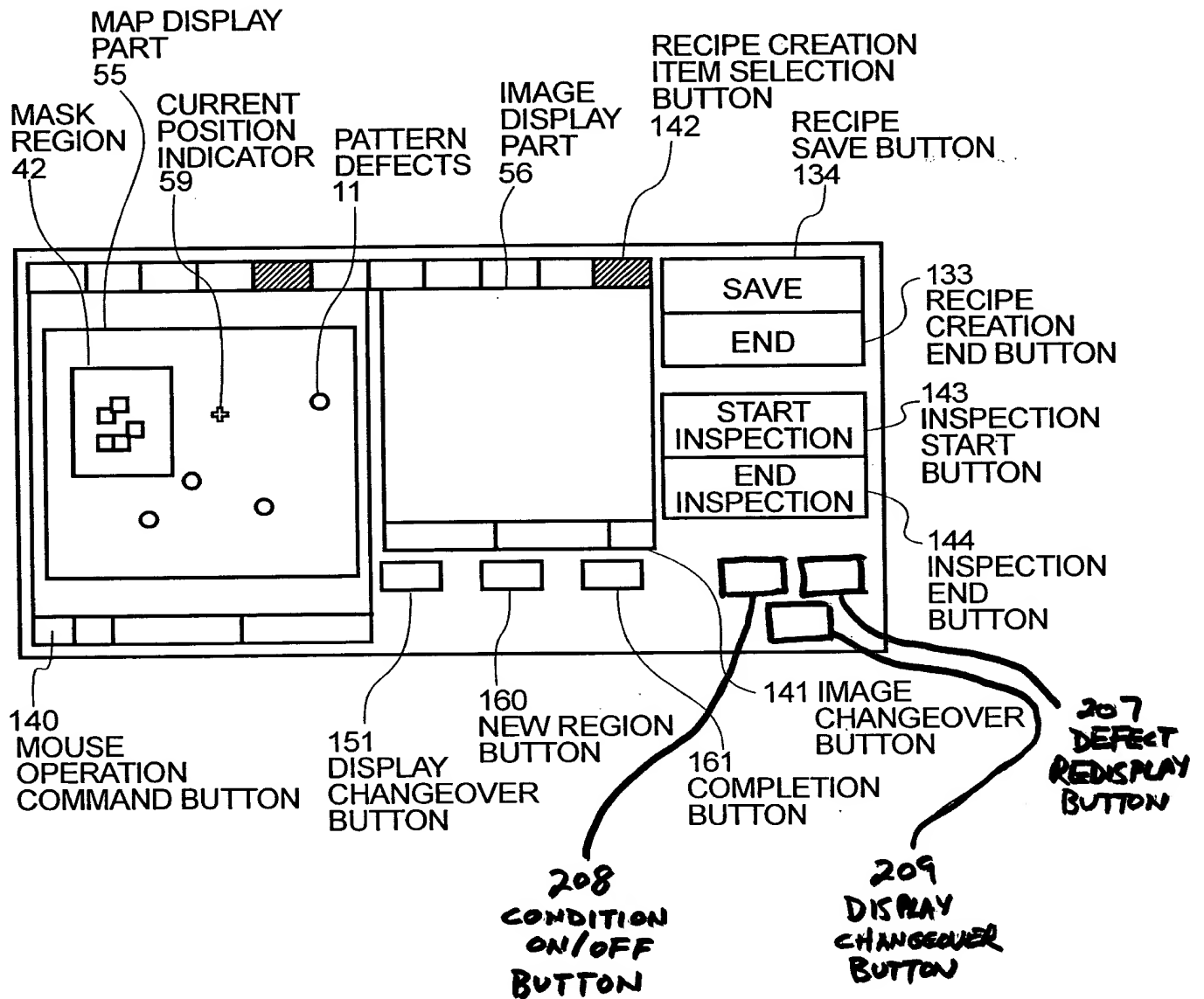
Melvin Kraus  
Registration No. 22,466  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee  
Attachment(s)  
(703) 312-6600

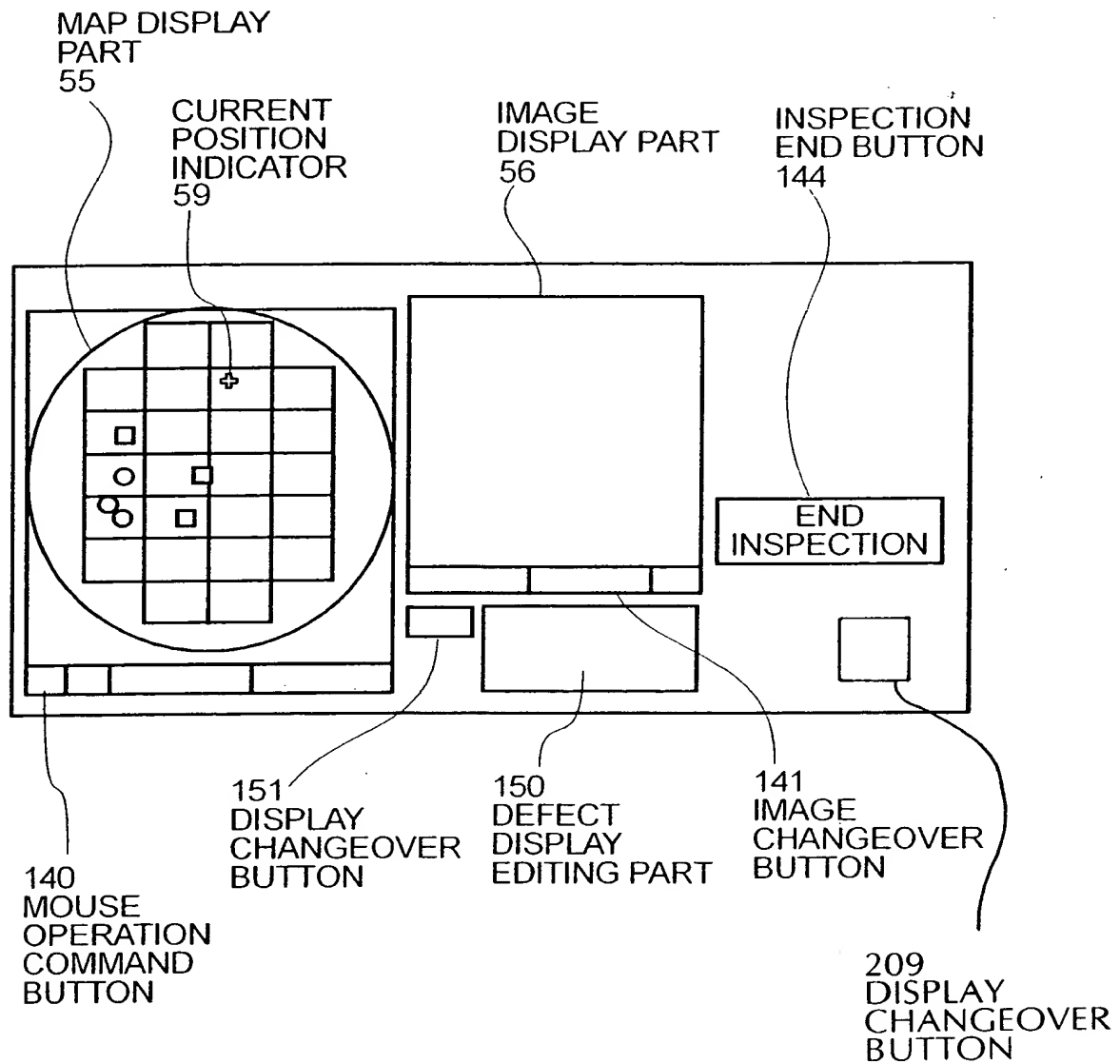
FIG.15



# FIG.17



**FIG.15**



# FIG.17

